



BOX AFTER FINAL

Free

In re the Application of:

Kyu-Dong JUNG, et al.

Art Unit: 2813

Serial No. 10/701,552

Examiner: Monica D. Harrison

Filed: November 6, 2003

Confirmation No. 8318

FOR: METHOD AND APPARATUS FOR VACUUM-MOUNTING A MICRO-ELECTRO MECHANICAL SYSTEM ON A SUBSTRATE

Attorney Docket No. 277/013

**REPLY UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va. 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action Made Final, mailed February 22, 2006, the following remarks are respectfully submitted in connection with the above-identified application:

**A Listing of the Claims** begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

not entered  
Monica D. Harrison  
6/23/06